



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 9391

SERIAL NUMBER 10/576,321	FILING or 371(c) DATE 04/19/2006 RULE	CLASS 438	GROUP ART UNIT 1722	ATTORNEY DOCKET NO. 12054-0059		
APPLICANTS Kazunari Kurita, Tokyo, JAPAN; Shinsuke Sadamitsu, Tokyo, JAPAN; Hiroyuki Takao, Tokyo, JAPAN; Masataka Hourai, Tokyo, JAPAN;						
** CONTINUING DATA ***** This application is a 371 of PCT/JP04/11050 08/02/2004						
** FOREIGN APPLICATIONS ***** JAPAN 2003-360251 10/21/2003						
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/14/2006						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/MARISSA W CHAET/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 5	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
ADDRESS CLARK & BRODY 1090 VERMONT AVENUE, NW SUITE 250 WASHINGTON, DC 20005 UNITED STATES						
TITLE Process for producing high-resistance silicon wafers and process for producing epitaxial wafers and soi wafers (as amended)						
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			